

APPLICATION NO.: 10/812,355
Docket: ES-040 (071469-0307699)

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re PATENT APPLICATION of:
YUE, Hongyu et al.

Confirmation Number: 4102

Application No.: ***10/812,355***

Group Art Unit: 1792

Filed: March 30, 2004

Examiner: CHEN, Kin Chan

Title: METHOD AND SYSTEM FOR ADJUSTING A CHEMICAL OXIDE REMOVAL
PROCESS USING PARTIAL PRESSURE

AMENDMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In reply to the Office Action dated August 1, 2008, please amend the above-identified application as follows:

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 4 of this paper.